

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/574,687	MORITA ET AL.	
Examiner	Art Unit	
Taevoon Kim	1651	

SEARCHED				
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
EAST search (USPG-pub;USPAT;USOCR;EPO;JPO;Derwe nt)	7/9/2008	TK		
Pubmed (keyword: patterning, polylysine, cell adhesion)	7/9/2008	TK		
Inventor search (PALM)	7/11/2008	TK		